

Generalization of longitudinal-lateral scheme for two-dimensional transient semiconductor device simulation

Gunko, V.B.; Kucherenko, S.S.; Kudryashov, N.A.; Sytsko, Yu.I. Automation, simulation & measurement : 3rd biennial conference : Tallinn, Estonia, October 7-11, 1991. Section S, Simulation = Automatiseerimine, modelleerimine ja mõõtmine : 3. rahvusvaheline konverents / Tallinna Tehnikaülikool 1992 / p. 107-112: ill https://www.ester.ee/record=b1064031*est

Numerical simulation of photoelectric processes in semiconductor devices

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